

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

IN RE APPLICATION OF:

Tadahiro OHMI, et al. GROUP: 1792

SERIAL NO: 10/591,294

FILED: August 31, 2006

EXAMINER: VINH, LAN

FOR: DISTRIBUTOR AND DISTRIBUTING METHOD, PLASMA PROCESSING
SYSTEM AND METHOD, AND PROCESS FOR FABRICATING LCD

SUBMISSION OF SUPPLEMENTAL APPLICATION DATA SHEET

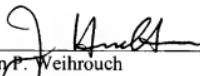
Office of Initial Patent Examination
Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

Sir:

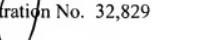
Applicant(s) submit herewith a Supplemental Application Data Sheet for the above-identified application for the purpose of correcting the inventors' cities of residence which appear incorrectly on the original Application Data Sheet.

Respectfully Submitted,

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